

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Tadahiro OHMI, et al.

Group Art Unit: 3748

Serial No.: 09/864,376

Examiner: Zervigon, Ruby

Filed: March 25, 2001

Docket No.: 107176-00007

For: PLASMA PROCESSING APPARATUS AND PLASMA  
PROCESSING METHOD

AMENDMENT UNDER 37 C.F.R. § 1.121

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

September 30, 2003

Sir:

In response to the outstanding Office Action dated May 30, 2002, the time for reply having been duly extended until September 30, 2003, by the attached petition, please amend the application as follows:



RECEIVED  
OCT 06 2003  
TC 1700